



Appl. No. 10/099,840

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.10/099,840
Confirmation No.5306
Filing DateMarch 12, 2002
Inventor.....James J. Hofmann
Assignee.....Micron Technology, Inc.
Group Art Unit2818
Examiner Hoang, Quoc Dinh
Attorney's Docket No.MI22-1803
Customer No.21567
Title: Methods of Forming Patterns for Semiconductor Constructions; and Molds
Configured to Patterned Masses Associated with Semiconductor Constructions

RESPONSE TO MAY 30, 2003 OFFICE ACTION

To: Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: Robert C. Hyta (Tel. 509-624-4276; Fax 509-838-3424)
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AMENDMENTS

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